



Ben Volk, Jr.

Partner

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PRACTICES

- Intellectual Property

EDUCATION

- University of Missouri-Columbia School of Law, J.D., 2000, Order of the Coif
- The Ohio State University, B.S., Electrical and Computer Engineering, 1997, Academic All-Big Ten, 1995, 1996, 1997

ADMISSIONS

- Missouri
- U.S. Patent & Trademark Office

AFFILIATIONS

- Bar Association of Metropolitan St. Louis (BAMSL)
- Missouri State Bar
- U.S. Patent and Trademark Office
- American Bar Association

EMPLOYMENT

- Thompson Coburn LLP Partner, 2009-Present Associate, 2001-2008
- Howell & Haferkamp, L.C. Associate, 2000-2001

Ben brings a background in electrical and computer engineering to his legal practice, which primarily focuses on the preparation and prosecution of patent applications.

In particular, Ben works closely on patents related to sophisticated digital electronics, including high performance stream processing platforms, artificial intelligence applications, mobile applications, and cloud computing, as well as medical imaging technology, and financial services technology.

He also provides counseling to clients on issues such as licensing, patent infringement, and patent invalidity, particularly in connection with products in development.

In addition to a J.D., Ben holds a Bachelor's degree in Electrical and Computer Engineering from The Ohio State University.

Industries

- Intellectual Property

Publications

- "USPTO Outlines Possible Pitfalls For Attorneys Using AI," *Law360*, April 10, 2024

Recognitions

- Listed in The Best Lawyers in America® (by BL Rankings), 2021-2025
- Named Lawyer of the Year for Patent Law in St. Louis by Best Lawyers (by BL Rankings), 2025